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Docket No.: P9219.0003
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Toshiyuki Oohashi et al.

Application No.: 10/689,041

Confirmation No.: 4665

Filed: October 21, 2003

Art Unit: 2832

For: MAGNETIC SENSOR, PRODUCTION
PROCESS OF THE MAGNETIC SENSOR
AND MAGNETIC ARRAY SUITABLE FOR
THE PRODUCTION PROCESS

Examiner: B. Rojas

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed May 5, 2004, Applicant hereby provisionally elects claim 1 for continued examination without traverse.

The Examiner has required restriction between:

Group I: Claim 1, drawn to a magnetic sensor with a magnetoresistive element;

Group II: Claims 2-4, drawn to the method of producing a magnetic sensor with a magnetoresistive element; and

Group III: Claims 5-9, drawn to a permanent magnet array.

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Applicants reserve the right to file one or more divisional applications directed to the subject matter of the non-elected claims.

Consideration and allowance of the application is respectfully solicited.

Dated: June 4, 2004

Respectfully submitted,

By 

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